

An Analysis of the Economics of Photomask Manufacturing Part – 1: The Economic Environment

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ISMT Mask Automation Workshop

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Problem Statement

- The cost of producing photomasks
 - has increased by an order of magnitude over the last decade,
 - and is likely to continue to escalate for the 90-nm technology node and beyond.
 - Ultimately the cost of photomasks may rise to the point where it threatens the profit potential of most low volume designs.
- Suppliers of photomasks are thus looking for ways to reduce the cost of producing photomasks,
- and semiconductor manufacturers are looking for creative ways to amortize them.

ISMT Project LITG323

“Mask Industry Assessment”

- Conducted by
 - Portland State University’s (PSU)
 - Maseeh College of Engineering and Computer Science’s (MCECS)
 - Department of Engineering and Technology Management (ETM)
- Principal Investigators:
 - C. Neil Berglund – Portland State University
 - Charles M. Weber – Portland State University
- Purpose:
 - Investigate the economics of photomask manufacturing
 - Provide input into annual mask industry survey

Research Question

- What can a supplier of photomasks do to enhance the profitability of its customers, in addition to augmenting his/her own profitability?

Research Methods

- Interviews with two dozen experts
 - Photomasks and related disciplines
- Data have been transcribed, coded and analyzed.
- Numerical model of the semiconductor lifecycle
- Leads to stylized facts concerning
 - the economics of photomask fabrication,
 - and profitability in semiconductor manufacturing.
- Please see reference (Weber, 2003, Ch. 3) for details.

The Mask Shop's Perspective

- Finite demand.
 - Global market for photomasks <\$3 billion (Kimmel, 2003@ BACUS)
 - Unit revenues for masks erode over time.
- Capital-intensive industry. Investment levels.....
 - ~\$40M for 'conventional' (180-nm node or above)
 - >\$100M for 'advanced' (130-nm node and beyond)
 - Photomask manufacturers fund making advanced masks from making conventional masks.
- Few players can afford to be in business.

State of Affairs

(Industry Survey by Kurt Kimmel @ BACUS, 2003)

- Mask business growth rate is 6.8%, as compared to 9% in semiconductors
- Currently <180-nm masks drive 37% of revenue (15% of mask shop volume).
- Small, but growing portion of masks require advanced resolution enhancement techniques.
- Hard defects are the primary yield problem!
- Severe data management issues
- 4 merchants control 65% of market
- Things will get worse as features shrink.

Expected Mask Costs for Future Technology Nodes

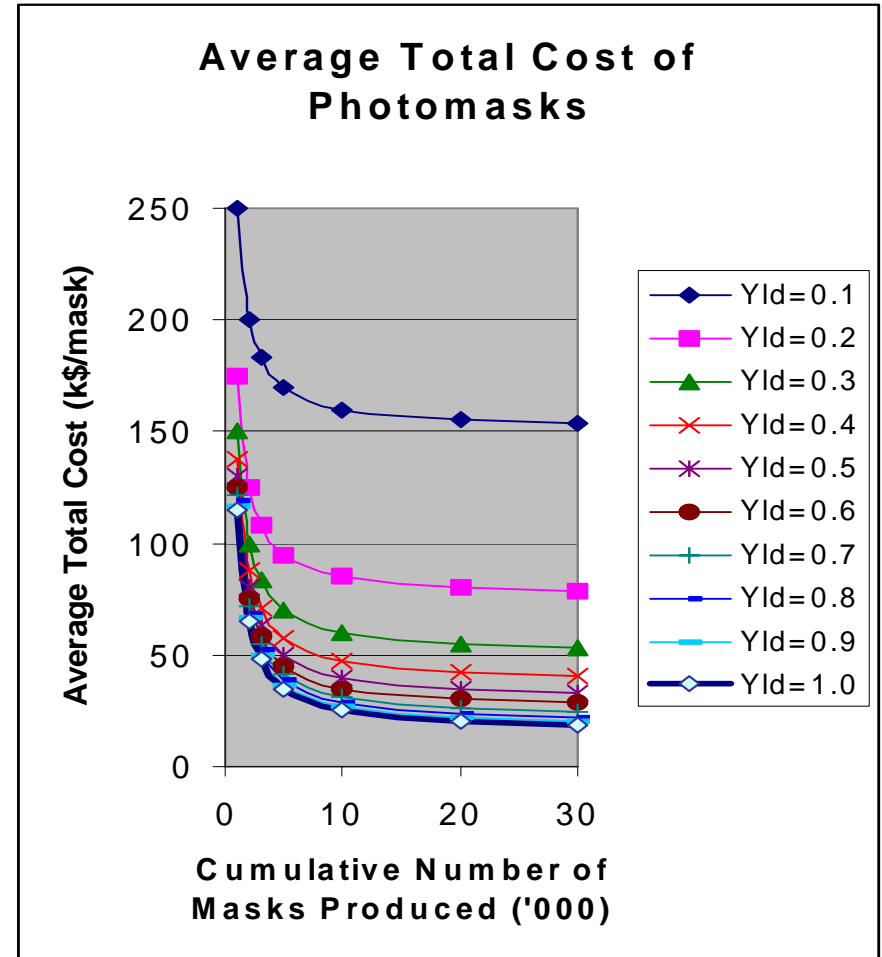
(Source: International Sematech)

- \$0.5M per mask set for 130-nm node
- \$1M per mask set for 90-nm node
- \$2M per mask set for 65-nm node

Mask Shop Experience Curve: *Advanced Masks*

(Weber, Berglund, Gabella, 2004)

- >50% yield is critical for profitability.
- Amortization of fixed costs complete after 20,000 masks.
- Maximize equipment utilization.



Average Total Cost of Critical Layer Photomasks
Assumptions: variable costs equal \$15k per mask;
fixed costs of \$100 million need to be amortized.

Initial Recommendations

- Improve yield rapidly.
 - Mask operations are similar to fab operations.
 - Transfer knowledge from customer.
 - However, yield knowledge is tacit (Polanyi, 1966).
 - Personnel transfer and extensive training is required.
 - How many yield engineers can a mask shop afford?
- Centralize mask making to enhance capital productivity.

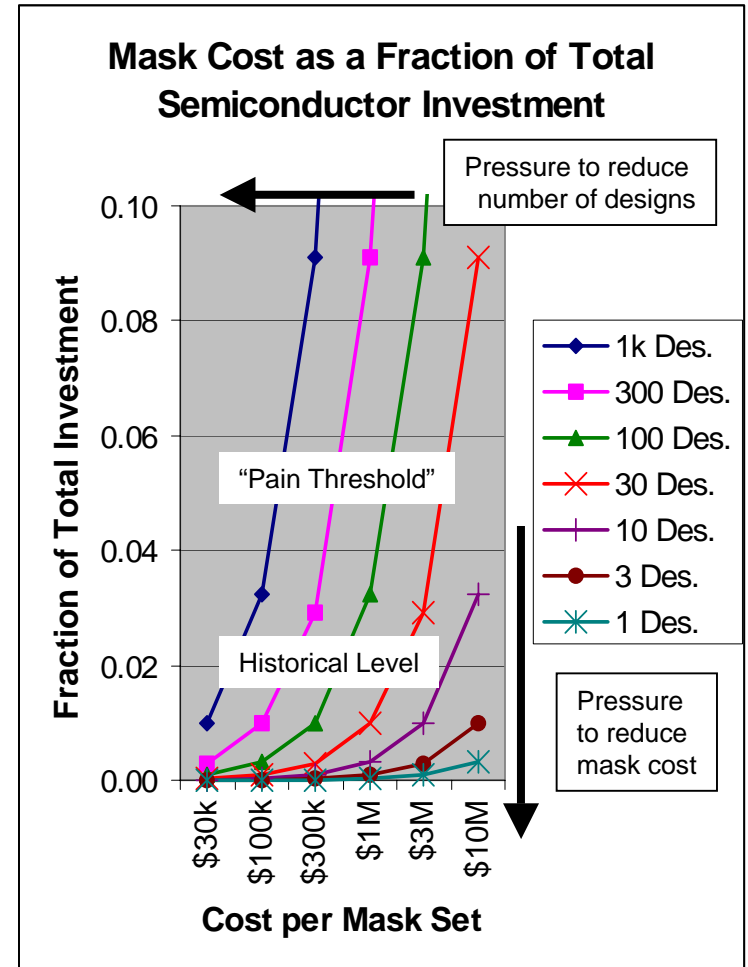
The Chipmakers' Perspective

- Amortization challenges
- Limited effects of yield learning for foundries and ASIC manufacturers
- The Designer's Learning Cycle
- Rapid turn-around time
- Shorter product lifetimes
- Early versus mature masks

Price Reduction or Market Shrinkage

(Weber, Berglund Gabella, 2004)

- If mask costs cannot be reduced,
- Then pressure to reduce the number of designs increases.
- Fewer designs means market shrinkage.
- Foundries and ASIC vendors are affected disproportionately. (Trybula, Intl. Sematech)

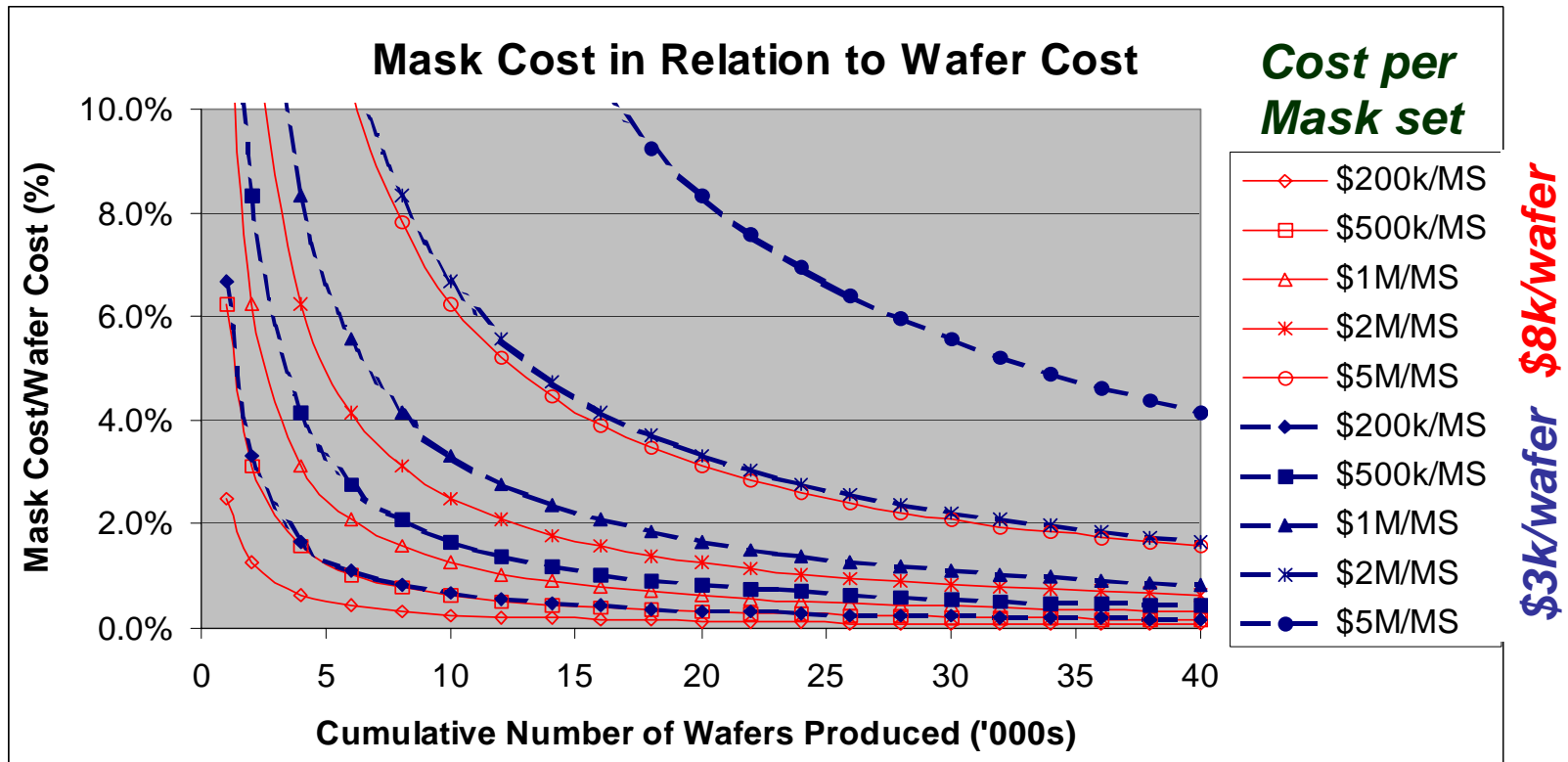


Model assumes a billion chips over the lifetime of a factory, a total investment of \$3billion excluding photomasks.

Amortization Challenges for Foundries and ASIC Vendors

- Only best sellers can be printed.
- 10,000 new designs in 2000
- Only 3500 new designs in 2003
- Drop cannot be completely explained by the economic downturn.

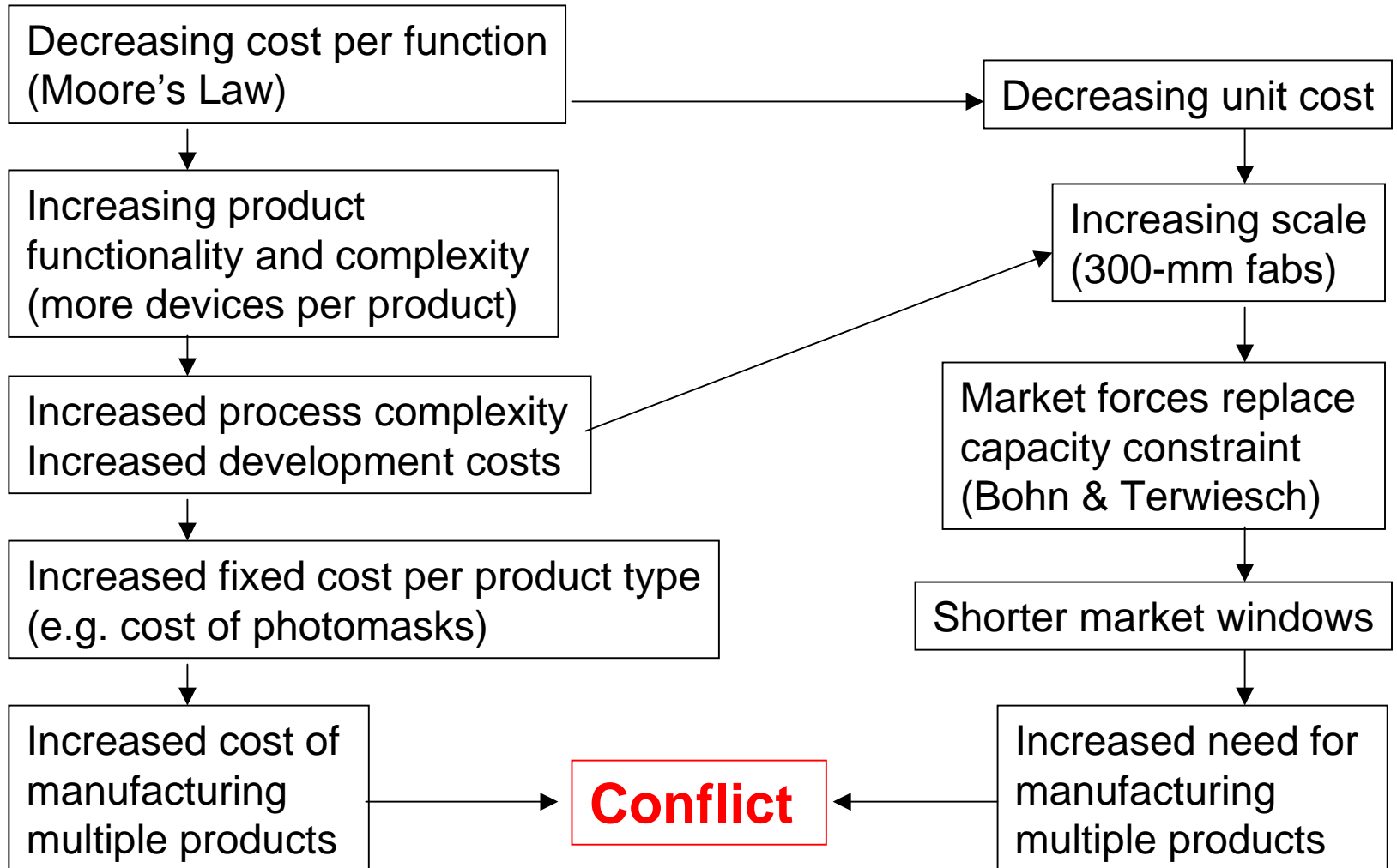
Mask Cost and Wafer Cost



Calculations assume 400 fully functional chips per wafer.

- **>20,000 300-mm wafers need to be produced for a 65-nm mask set to be amortized.**

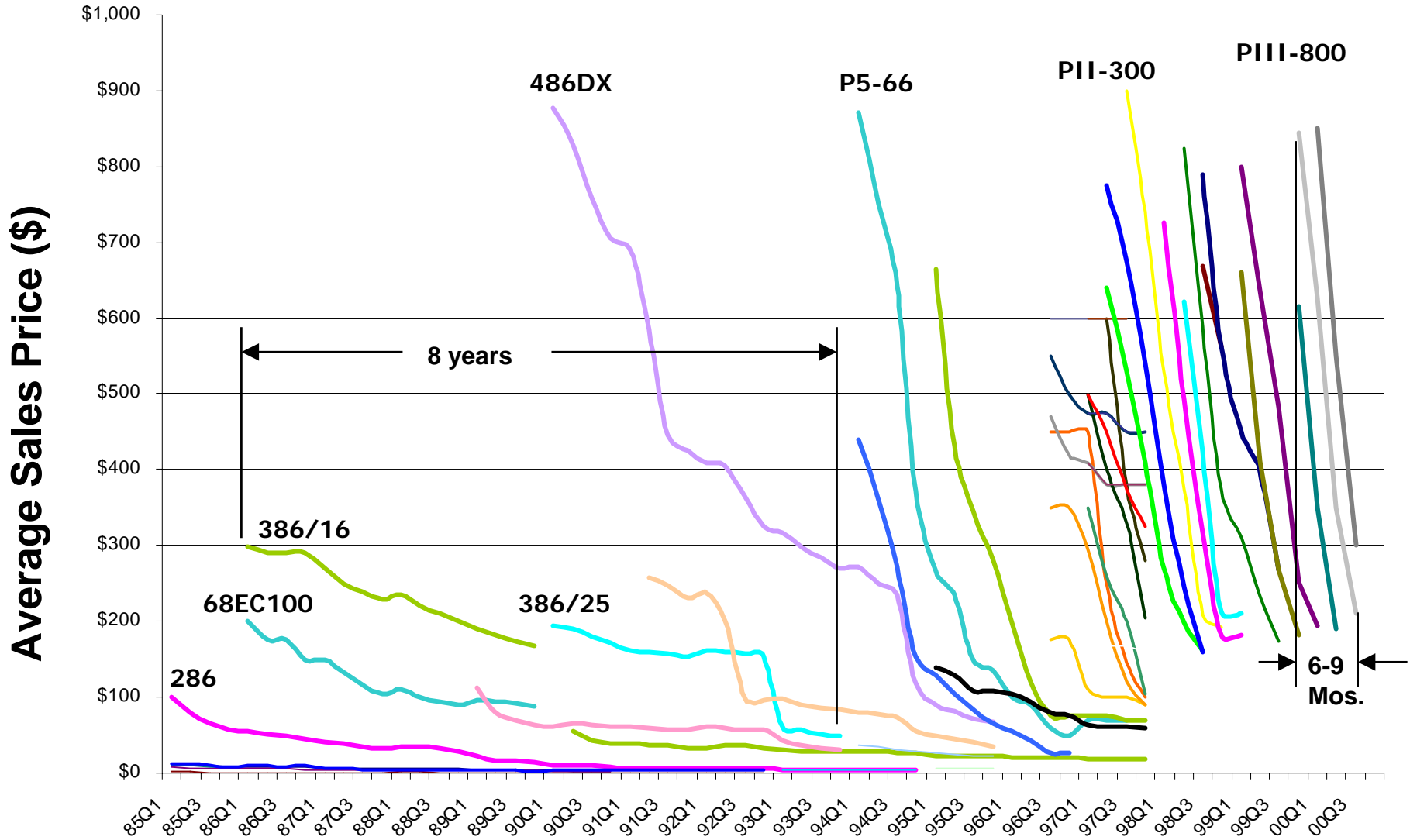
Scale versus Scope in Semiconductor Manufacturing



Scale versus Scope

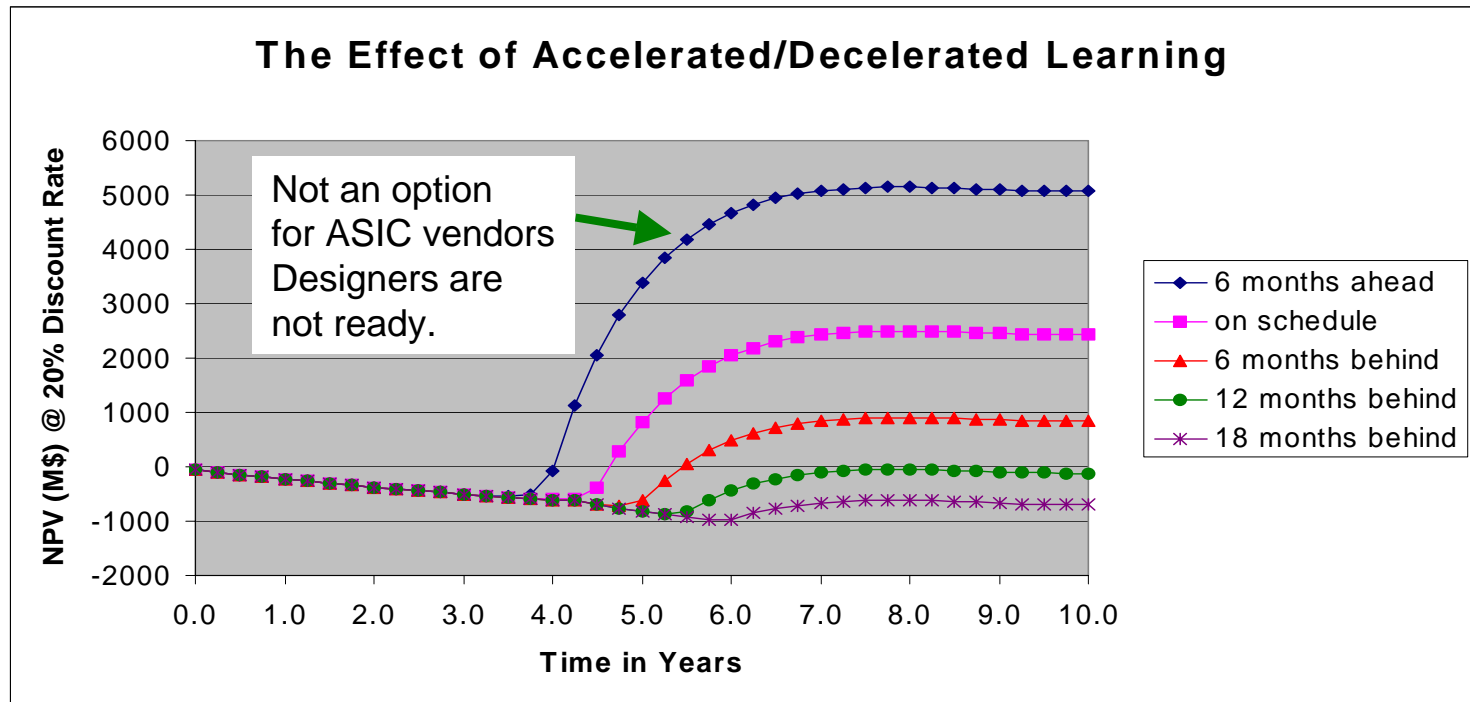
- A firm enjoys ***economies of scale*** when it can double its output at less than twice the cost. (Pindyck & Rubinfeld, p. 223)
- ***Economies of scope*** are present when the joint output of a single firm is greater than the output that could be achieved by two different firms each producing a single product (with equivalent production inputs allocated between the two firms). (Pindyck & Rubinfeld, p. 227)

Logic Life Cycle Drives the Industry



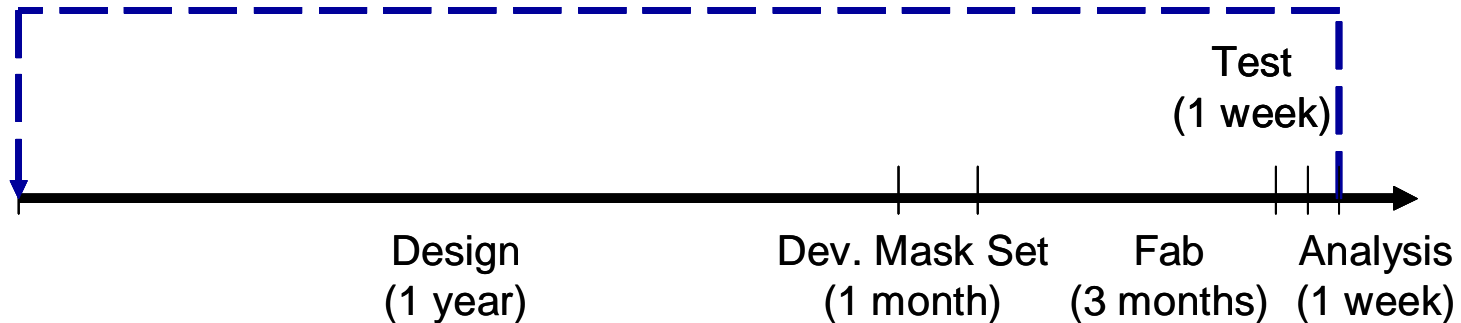
Life cycle is decreasing rapidly. (Source: Walt Trybula, Intl. Sematech)

Limits Effects of Yield Learning in ASIC Manufacturing (Weber, 2002)



- ASIC manufacturer profitability in a 200-mm wafer fab.
- When venture is on schedule, one minute on the critical path amounts to \$2500.

The Designer's Learning Cycle

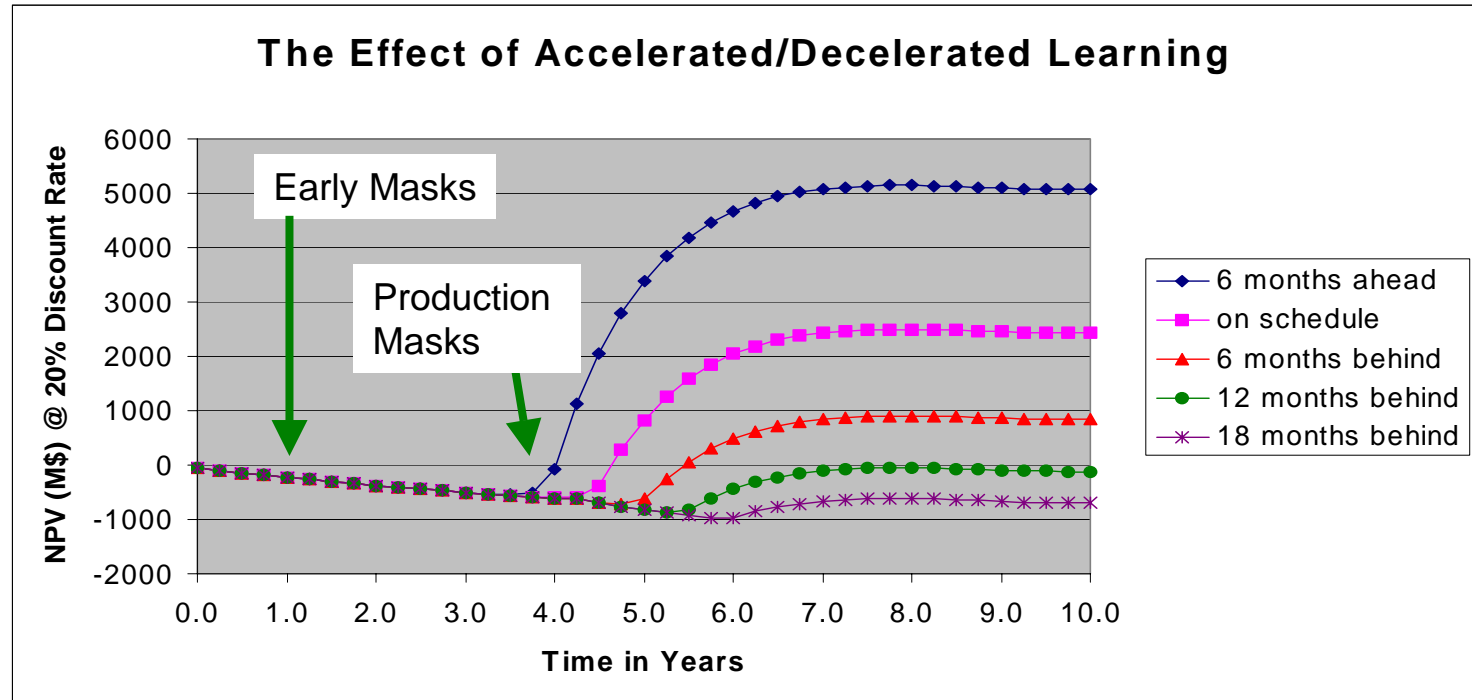


- Full learning cycle can take more than 15 months.
- Market fluctuates much faster. (Sematech GEM)
- Only end user firms with long planning horizon can afford to design chips.

Rapid Turn-Around

- Fab problems can cost \$10,000 per minute. (Weber & von Hippel, 2000)
- Inter-continental delivery of masks is unacceptable to many fabs.
- Mask maker must build fabs close to customers. Centralization is very difficult.
- Capital productivity of mask shops drops.

Early Masks vs. Production Masks



- **Early masks:** low volume; low yield; long turnaround; very high cost; very high price.
- **Production masks:** moderate volume; higher yield; short turn around; relatively lower cost; much lower price.
- A mask shop that cannot make early masks won't get business downstream.

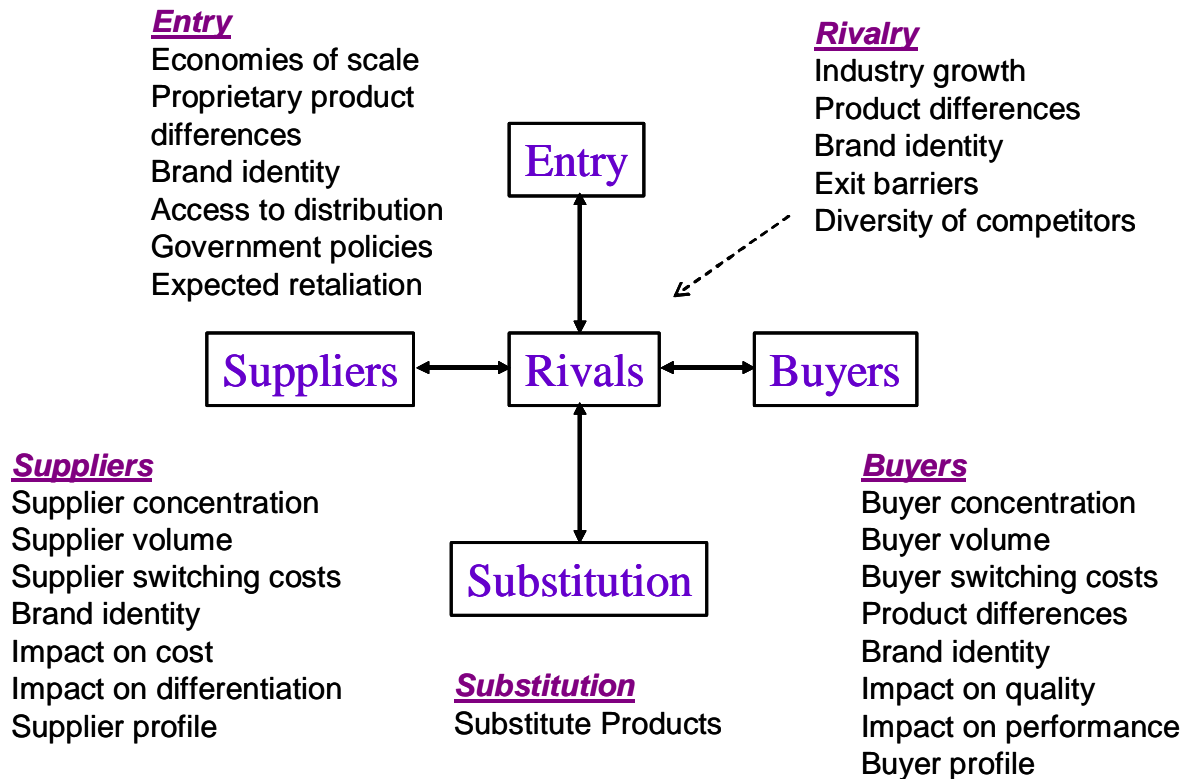
Summary

- For mask shops
- Reducing defects is not enough.
- Rapid yield improvement efforts may not be affordable.
- Rapid turnaround prevents full utilization of equipment.
- Cost reduction or market shrinkage
- Enormous consolidation pressure
- Market segmentation: advanced versus conventional.

Recommendations for Mask Shops

- ITRS: Move the mask problem onto the near-term problem list.
- Coordinated development:
 - Align mask development with leading customers (chipmakers) and complementors (e.g. stepper manufacturers, resist suppliers)
- Develop pricing strategies with customers.
- Joint ventures with customers.
- Merge!

Currently in Tech Transfer: Strategic Threat Analysis for the Photomask Industry



- Based on Porter Model

Currently under Investigation: **Best Practices for Mask Industry**

- A list of best practices suggested by analysis of economic environment is in tech transfer.
- Additional questions regarding best practices may be included in 2005 mask survey.

Currently under Investigation: **Scenarios for Evolution of the Semiconductor Industry**

1. Technical Substitutions for Photomasks
 - Maskless Lithography
2. Operational Solutions
 - Fewer critical masks per mask set
3. Vertical Integration of Advanced Mask Making
4. Bifurcation of Moore's Law
 - DRAM and Microprocessors on accelerated schedule
 - ASIC and perhaps foundries on slower schedule

Interim Conclusions

- A combination of scenarios 1-4 is likely to occur.
- Severe consolidation pressure for all four scenarios.
- The patterning problem may cause a restructuring of the semiconductor industry.
- Factory automation and operational efficiency are becoming critically important.

Factory Automation and Operational Efficiency in Fabs and Mask Shops

R.C. Leachman (UC Berkeley); C. Weber, C. N. Berglund (Portland State U.)

Problem Statement:

- Capital investments in the billions (100s millions) of dollars
- Profitability depends on operational efficiency.
- Processes, manufacturing environment and economic environment are highly complex.
- Highly dynamic manufacturing environment.
- Critical decisions must be made in real time.
- Real-time decisions may have to be based on simulations of fab and economic environment.

Limits of Many Approaches:

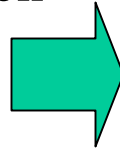
- Wrong evaluation metric → wrong answer!
 - *Wafer cost or even die cost are insufficient!*
- Models that do not cover the complete investment horizon give the wrong answer!
- Models that do not assess risk are of little value!
- Insufficient number of managerial variables
 - Management responses tend to be multidimensional.
 - Need to make *Apples-to-oranges comparisons!*
- Models do not run in real time.

The Value of Ownership Model

R.C. Leachman (UC Berkeley); C. Weber, C. N. Berglund (PSU)

Configurable, Real-time, dynamic factory simulation

- Predicts factory behavior
- Covers complete economic environment
- Spans required investment horizon
- Comprehends variability.
- *Gets the right answer!*
- Drives decisions.



Value of Ownership Approach

- Gives real-time assessment of impact on bottom line
- Latest data and latest expectations are entered into simulation.
- Simulation
 - **generates potential scenarios for action;**
 - **assigns \$ value to each scenario;**
 - **assesses risk for each scenario.**
- Managers choose the best scenario.
- *Ultimate MC Benefits:* rapid, data-driven decision making capability based on \$ value.

Project Implementation

- Collaborative development of e-manufacturing infrastructure
- Scalable models
- Three-year project horizon
- Intended start date: Fall 2005

